



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **FUKUDA, et al.**

Serial No.: **10/607,013**

Group Art Unit: **2823**

Filed: **June 27, 2003**

Examiner: **GARCIA, Joannie A.**

Confirmation No.: **4970**

For: **SEMICONDUCTOR SUBSTRATE AND METHOD FOR FABRICATING THE SAME**

**RESPONSE TO RESTRICTION REQUIREMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

February 9, 2004

Sir:

This paper is submitted in response to the Official Action dated January 13, 2004

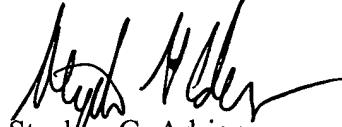
In the Action, restriction is required between Group (I), Claims 1-10, drawn to a device;  
and Group (II), Claims 11-24, drawn to a method.

Applicants hereby elect the subject matter of Group (I), Claims 1-10 for prosecution in  
this application. This election is made **without** traverse, it being understood that the applicant's  
rights to the filing of a divisional application directed to the non-elected subject matter under 35  
USC 120 and 35 USC 121 are retained.

In the event that this paper is not timely filed, Applicants respectfully petition for an appropriate extension of time. Please charge any fees for such an extension of time and any other fees which may be due with respect to this paper, to Deposit Account No. 50-2866.

Respectfully submitted,

WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP



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